

Electronic Patent Application Fee Transmittal

Application Number:	10627611			
Filing Date:	28-Jul-2003			
Title of Invention:	METHOD OF FABRICATING X-RAY MASK AND METHOD OF FABRICATING SEMICONDUCTOR DEVICE USING THE X-RAY MASK			
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Attorney Docket Number:	402721			
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Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Utility Appl issue fee	1501	1	1400	1400
Publ. Fee- early, voluntary, or normal	1504	1	300	300

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Miscellaneous:				
Printed copy of patent - no color	8001	6	3	18
Total in USD (\$)				1718